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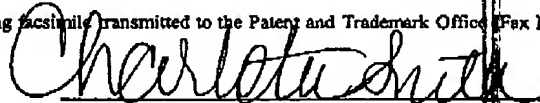
Docket No. 74019-1041

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Takeshi YAMASHITA et al.) Group Art Unit: 1765
Serial No. 10/759,180) Examiner: Not Yet Assigned
Filed: January 20, 2004) Confirmation No.: 7694
For: *DRY ETCHING METHOD,
FABRICATION METHOD FOR
SEMICONDUCTOR DEVICE, AND DRY
ETCHING APPARATUS*

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I hereby certify that this correspondence is being facsimile transmitted to the Patent and Trademark Office (Fax No. (703)872-9306) on May 4, 2005.

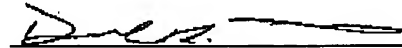

Name: Charlotte M. Smith**STATUS INQUIRY**

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Please advise, in writing, as to the current status of the above-identified application.

Respectfully submitted,



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May 7, 2005

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